CERTIFICATE OF Applicant(s): Hiroshi Ki	TRANSMISSION BY FAC										
Serial No. 09/837,022	Filing Date April 18, 2001	Examiner James Michell		Group Art Unit	er y						
Invention: SEMICONDUCTOR DEV	TCE, ITS MANUFACTURING N	METHOD AND ELECTRO DE	EPOSIT	TION FRAME FIECEIVE							
				CENTRAL FAX C	D ENTER 03						
I her by certify that this Supplemental Amendment After Final and KIMURA 1.132 Declaration  (Identify type of correspondence) is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. 703-872-9319											
on December 1 (Date)			_								
Michael S. Gzybowski  (Typed or Prinsed Name of Person Signing Certificate)  Michael Sign mon 82											
		Signatura	<i>,</i>								
Note: Each paper must have its own certificate of mailing.											

AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Hiroshi KIMURA						Docket No. 121056-020					
7		g Date 18, 2001	Examiner James Michell			Group Art Unit 2827					
Invention: SEMICONDUCTOR DEVICE, ITS MANUFACTURING METHOD AND ELECTRO DEPOSITION FRAME											
TO THE COMMISSIONER FOR PATENTS:											
Transmitted herewith is an amendment in the above-identified application.  The fee has been calculated and is transmitted as shown below.											
CLAIMS AS AMENDED											
	CLAIMS	REMAINING	HIGHEST #	NUMBER EXTRA			ADDITIONAL				
		AMENDMENT	PREV. PAID FOR		RA	ITE (	FEE				
TOTAL CLAIMS	4	-	20 =	0	×	\$18.00	\$0.00				
INDEP. CLAIMS	1	-	3 =	0	x	\$86.00	\$0.00				
Multiple Dependent Claims (check if applicable)											
	TOTAL ADDITIONAL FEE FOR THIS AMENDMENT \$0.00										
No additional fee is required for amendment.  Please charge Deposit Account No. in the amount of  A check in the amount of to cover the filing fee is enclosed.  The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No.  Any additional filing fees required under 37 C.F.R. 1.16.  Any patent application processing fees under 37 CFR 1.17.  Dated: December 18, 2003											
Filed via facsimile	transmi:	ssion.		on first class ma Commissione 22313-1450.	il under 3 or for Pak	with the property of the prope	If fee is being deposited the U.S. Postal Service as B and is addressed to the lox 1450, Alexandria, VA g Correspondence				

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Appl. No. 09/837,022 Response. Dated December 18, 2003 Reply to Office Action of July 1, 2003

## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group

Art Unit:

2827

Attorney

Docket No.:

121056-020

Applicant:

Hiroshi KIMURA

Invention:

SEMICONDUCTOR

DEVICE.

ICE, ITS

MANUFACTURING METHOD ELECTRO DEPOSITION FRAME

Serial No:

09/837,022

Filed:

April 18, 2001

Examiner:

James Mitchell

RESPONSE AFTER FINAL REJECTION

**EXPEDITED PROCESSING REQUESTED** 

Certificate Under 37 CFR 1.8(b)

I hereby certify that this correspondence is being transmitted to the United States Patent and Trademark Office via facsimile transmission on the date indicated below.

on <u>December 18, 2003</u>

SUPPLEMENTAL AMENDMENT AFTER FINAL REJECTION
SUBMISSION OF KIMURA DECLARATION

Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In further response to the Official Action mailed July 1, 2003 in connection with the aboveidentified application, please amend the application as follows.

Amendments to the claims are reflected in the listing of the claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.